

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 118215		APPLICATION NO. New US Application	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANTS Mutsumi KIMURA et al.			
				FILING DATE January 27, 2004			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
1	1	JP A 6-308872 (with abstract and translation)	11/04/1994	Japan			
2	2	JP A 2003-297974 (with abstract and translation)	10/17/2003	Japan			
3	3	JP A 2003-142666 (with abstract and translation)	05/16/2003	Japan			
4	4	JP A 2003-298006 (with abstract and translation)	10/17/2003	Japan			
5	5	JP A 2001-282423 (with abstract and translation)	10/12/2001	Japan			
6	6	JP A 2001-282424 (with abstract and translation)	10/12/2001	Japan			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
7	7	"A breakthrough technology...for leading edge microelectronics manufacturing"., www.holtronic.ch,					
EXAMINER				DATE CONSIDERED			
[Signature]				5/16/05			
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: January 27, 2004

Date: February 17, 2004